Se	arch No	tes

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/029,300	IWASAKI, TAKAO	
Examiner	Art Unit	
Jacob P. Rohwer	2625	

	SEAR	CHED	
Class	Subclass	Date	Examiner
358	1.13	6/27/2005	JPR
382	232	6/27/2005	
1			

INT	INTERFERENCE SEARCHED		
Class	Subclass	Date	Examiner
	0.0		

SEARCH NO (INCLUDING SEARCH)
	DATE	EXMR
East Class 358 (text search only)	6/28/2005	JPR
East Class 382 (text search only	6/30/2005	JPR
East Class 358 (Updated text search)	11/17/2005	JPR
East (Text Search Update)	4/7/2006	JPR
	-	1